

Application No.

Applicant(s)

09/862,814

John C. Seibel et al.

Docket Number

Group Art Unit

Filing Date

068082.0114

2177

5/21/01

**Information Disclosure Citation
in an Application**

U.S. PATENT DOCUMENTS

	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
A	6029141	02/22/00	Bezos et al.	705	27	06/27/97
B	6055510	04/25/00	Henrick et al.	705	14	10/24/97
C	6154766	11/28/00	Yost et al.	709	201	06/30/99
D	6434544 B1	08/13/02	Bakalash et al.	707	2	02/28/00
E	6477536 B1	11/05/02	Pasumansky et al.	707	102	06/22/99
F	6557008 B1	04/29/03	Temple, III et al.	707	104.1	12/07/99
G	6574619 B1	06/03/03	Reddy et al.	707	2	03/24/00
H	6651055	11/18/03	Kilmer et al.	707	3	03/01/01
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FOREIGN PATENT DOCUMENTS

	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
N	99/66446	12/23/99	WO	G06K	5/00	x	
O	00/23929	04/27/00	WO	G06F	17/60	x	
P	01/22692	03/29/01	WO	H04M		x	

NON-PATENT DOCUMENTS

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PTO-1449		Application No. 09/862,814		Applicant(s) Seibel et al.		
Information Disclosure Citation in an Application		Docket Number 068082.0114		Group Art Unit 2177	Filing Date May 21, 2001	
U.S. PATENT DOCUMENTS						
	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
A.	5787422	7/28/98	Tukey et al.	707	5	1/11/96
B.	5999927	12/7/99	Tukey et al.	707	5	4/24/98
C.	6151601	11/21/00	Papierniak et al.	707	10	11/12/97
D.	6233575	5/15/01	Agrawal et al.	707	6	6/23/98
E.	6263334	7/17/01	Fayyad et al.	707	5	11/11/98
F.	6490582	12/3/02	Fayyad et al.	707	6	2/8/00
G.	6567797	5/20/03	Schuetze et al.	707	2	10/19/99
H.	6598054	7/22/03	Schuetze et al.	707	103	10/19/99
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EXAMINER <i>[Signature]</i>				DATE CONSIDERED 7/14/2004		
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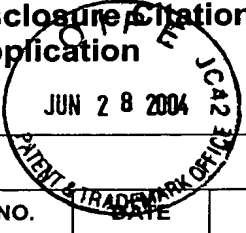
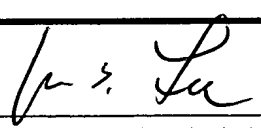
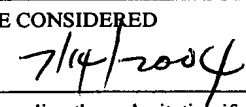
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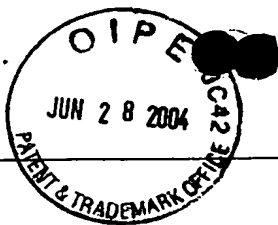
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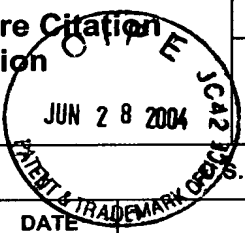
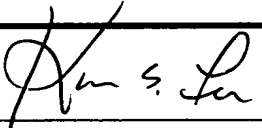
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				U.S. PATENT DOCUMENTS					
		DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE		
A.		5809481	9/15/98	Baron et al.	705	14	8/8/96		
B.		5924068	7/13/99	Richard et al.	704	260	2/4/97		
C.		5987247	11/16/99	Lau	395	702	5/9/97		
D.		6026433	2/15/00	D'Arlach et al.	709	217	3/17/97		
E.		6029174	2/22/00	Sprenger et al.	707	103	10/31/98		
F.		6058398	5/2/00	Lee	707	104	5/24/99		
G.		6105055	8/15/00	Pizano et al.	709	204	3/13/98		
H.		6256623	7/3/01	Jones	707	3	6/22/98		
I.		6289342	9/11/01	Lawrence et al.	707	7	5/20/98		
J.		2002/0016735	2/7/02	Runge et al.	705	14	4/17/01		
K.		6381599	4/30/02	Jones et al.	707	5	11/15/99		
FOREIGN PATENT DOCUMENTS									
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L.		98/49641	11/5/98	WO	G06F	17/60	x		
M.		98/21679	5/22/98	WO	G06F	17/60	x		
N.		95/30201	11/9/95	WO	G06F	19/00	x		
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		DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE		
A.		6401091	6/4/02	Butler et al.	707	10	12/5/95		
B.		6430545	8/6/02	Honarvar et al.	706	47	12/21/98		
C.		6434548	8/13/02	Emens et al.	707	3	12/7/99		
D.		6438543	8/20/02	Kazi et al.	707	5	6/17/99		
E.		6473756	10/29/02	Ballard	707	6	6/11/99		
F.		6480842	11/12/02	Agassi et al.	707	4	3/25/99		
G.		6555738	4/29/03	Hughes et al.	84	609	4/20/01		
H.		6567803	5/20/03	Ramasamy et al.	707	4	5/31/00		
I.		6581054	6/17/03	Bogrett	707	4	7/30/99		
J.		2003/0139975	7/24/03	Perkowski	705	26	12/12/02		
K.		6625598	9/23/03	Kraffert	707	3	10/25/00		
L.		6651065	11/18/03	Brown et al.	707	10	11/30/01		
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		DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
a	A.	6665658	12/16/03	DaCosta et al.	707	3	1/13/00
b	B.	6677963	1/13/04	Mani et al.	345	764	11/16/99
h	C.	6684218	1/27/04	Santos et al.	707	102	11/21/00
g	D.	6684207	1/27/04	Greenfield et al.	707	3	8/1/01
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